



PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application No.: 10/606,854

Filing Date: June 26, 2003

Applicant: Jeffrey S. Hartlove et al.

Group Art Unit: 2828

Examiner: Tuan N. Nguyen

Title: LASER-PRODUCED PLASMA EUV LIGHT SOURCE
WITH PRE-PULSE ENHANCEMENT

Attorney Docket: NGC-00050 (48-0032)

Mail Stop Amendment
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

RESPONSE TO OFFICE ACTION

Sir:

In response to the Office Action mailed February 10, 2005, to which a response was due by May 10, 2005, Applicant hereby petitions under 37 C.F.R. § 1.136(a) for a one month extension of time in which to respond to the outstanding Office Action. Applicant has included a Petition for Extension of Time authorizing payment of the extension fee under 37 C.F.R. § 1.136(a) with this response. Please amend the application as follows and consider the remarks set forth below.

Amendments to the Claims are reflected in the listing of claims, which begin on page 2 of this paper.

Remarks begin on page 9 of this paper.